

CPW4-1200S005B-Silicon Carbide Schottky Diode Chip

Z-RECTM RECTIFIER

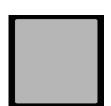
 $V_{RRM} = 1200 \text{ V}$

 $\mathbf{I}_{\mathsf{F}(\mathsf{AVG})} = 5 \; \mathsf{A}$

= 34.5 nC

Features

- 1200-Volt Schottky Rectifier
- Zero Reverse Recovery
- Zero Forward Recovery
- High-Frequency Operation
- Temperature-Independent Switching Behavior
- Extremely Fast Swtitching
- Positive Temperature Coefficient on V_F



Chip Outline

Part Number	Anode	Cathode	Package	Marking
CPW4-1200S005B	Al	Ni/Ag	Sawn on Foil	Wafer # on Foil

Maximum Ratings

Symbol	Parameter	Value	Unit	Test Conditions	Note
V _{RRM}	Repetitive Peak Reverse Voltage	1200	V		
$V_{\scriptscriptstyle RSM}$	Surge Peak Reverse Voltage	1300	V		
V _{DC}	DC Blocking Voltage	1200	V		
$I_{\text{F(AVG)}}$	Average Forward Current	5	А	T _j =175°C	
$I_{_{FRM}}$	Repetitive Peak Forward Surge Current	26	А	$T_c=25$ °C, $t_p=10$ ms, Half Sine Wave	1
\mathbf{I}_{FSM}	Non-Repetitive Peak Forward Surge Current	46	А	T _c =25°C, t _p =10 ms, Half Sine Wave	1
T_{j} , T_{stg}	Operating Junction and Storage Temperature	-55 to +175	°C		



Electrical Characteristics

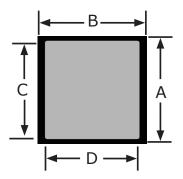
Symbol	Parameter	Тур.	Max.	Unit	Test Conditions	Note
V _F	Forward Voltage	1.4 1.9	1.8 3	V	$I_F = 5 \text{ A } T_J = 25^{\circ}\text{C}$ $I_F = 5 \text{ A } T_J = 175^{\circ}\text{C}$	
I _R	Reverse Current	20 40	150 300	μΑ	$V_R = 1200 \text{ V } T_J = 25^{\circ}\text{C}$ $V_R = 1200 \text{ V } T_J = 175^{\circ}\text{C}$	
Q _c	Total Capacitive Charge	34.5		nC	$V_{R} = 600 \text{ V}, I_{F} = 2 \text{ A}$ $di/dt = 500 \text{ A}/\mu\text{s}$ $T_{J} = 25^{\circ}\text{C}$	
С	Total Capacitance	390 27 20		pF	$V_R = 0 \text{ V, } T_J = 25^{\circ}\text{C, } f = 1 \text{ MHz}$ $V_R = 400 \text{ V, } T_J = 25^{\circ}\text{C, } f = 1 \text{ MHz}$ $V_R = 800 \text{ V, } T_J = 25^{\circ}\text{C, } f = 1 \text{ MHz}$	

Note: 1. Assumes θJC Thermal Resistance of 1.85°C/W or less

Mechanical Parameters						
Parameter	Тур.	Unit				
Die Size	1.69 x 1.69	mm				
Anode Pad Size	1.40 x 1.40	mm				
Anode Pad Opening	1.12 x 1.12	mm				
Thickness	377 ± 10%	μm				
Wafer Size	100	mm				
Anode Metalization (Al)	4	μm				
Cathode Metalization (Ni/Ag)	1.4	μm				
Frontside Passivation	Polyimide					



Chip Dimensions



symbol	dimension			
	mm	inch		
А	1.69	0.067		
В	1.69	0.067		
С	1.12	0.044		
D	1.12	0.044		

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The die-on-tape method of delivering these SiC die may be considered a means of temporary storage only. Due to an increase in adhesion over time, die stored for an extended period may affix too strongly to the tape. These die should be stored in a temperature-controlled nitrogen dry box soon after receipt. Cree will further recommend that all die be removed from tape to a waffle pack, to a similar storage medium, or used in production within 2 – 3 weeks of delivery to assure 100% release of all die without issues.